

International Journal of Engineering and Science Invention

e-ISSN: 2319 - 6734 p-ISSN: 2319 - 6726

CERTIFICATE

It is certify that the paper entitled by "Ultrathin Si Based Ag Thin Films: Prepared By DC Magnetron Sputtering" has been published in International Journal of Engineering and Science Invention (IJESI).

Your article has been published with following details:

Author's Name: R. Subba Reddy, A. Sivasankar Reddy, P. Sreedhara Reddy

Journal Name: International Journal of Engineering and Science Invention (IJESI)

Journal Web: www.ijesi.org

Journal Type: Online & Offline

Review Type: Peer Review Refereed

Publication Year: 2018

Publication Month: Oct

Vol No.: 07

Issue No.: 10



Editor-In-Chief

International Journal of Engineering and Science Invention (IJESI)

E-mail ID: ijesi@invmails.com

Web: www.ijesi.org

UGC Approval Serial Number: 2573 & UGC Journal Number: 43302